

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kaiping Liu

Art Unit: 2813

Division of Serial No.: 10/269,226

Examiner: Chandra P. Chaudhari

Filed: Herewith

Docket: TI-34717.1

For: Method to Produce Localized Halo for MOS Transistor

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Karen Vertz
Karen Vertz

2-24-04
Date

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Dear Sir:

Prior to the examination of the above-identified application, please amend as follows:

IN THE SPECIFICATION:

Please amend the Specification by inserting before the first line the following sentence:

--This is a division of Application No. 10/269,226, filed 10/11/2002, the entire disclosure of which is hereby incorporated by reference--.